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PATENT

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: Kazuyoshi NAMBA

Serial No.: 09/940,855

Group Art Unit: 1746

Filed: August 29, 2001

Examiner: Unassigned

For : SUBSTRATE CLEANING APPARATUS AND SUBSTRATE CLEANING METHOD

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents  
Washington, D.C. 20231

RECEIVED

JUN 06 2002

Sir:

TC 1700

Pursuant to the duty of disclosure under 37 C.F.R. 1.56, Applicant is enclosing an Information Disclosure Citation Form (PTO-1449) and a copy of the document cited therein.

U.S. Patent No. 6,286,525 B1 corresponds to JP laid open publication No. 10-308370A which is discussed in the "Description of the Related Art" section of the specification.

It is respectfully requested that the cited document be considered by the Examiner in the above-identified patent application and that the cited documents be made officially of record therein. It is further requested that a listing of the same appear on the face of any patent which may issue from this application.

This Information Disclosure Statement is being filed before receipt of a first Office Action in the present application, and therefore it is believed that no fees are due under 37 C.F.R. Section 1.97(i).

Respectfully submitted,


SMITH, GAMBRELL & RUSSELL, LLP



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Patent Trademark Office

June 4, 2002

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